



PATENT
Docket No. 740819-464

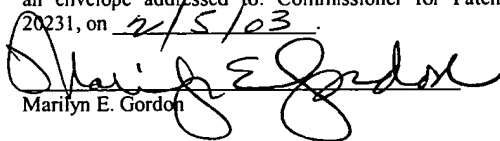
11/12/03
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Toshiya FUKUHISA) Group Art Unit: 2828
Serial No. 09/717,137 ✓) Examiner: Jeffrey N. ZAHN
Filed: November 22, 2000)
For: SEMICONDUCTOR LASER DEVICE) Date: February 5, 2003
AND METHOD FOR FABRICATING
THE SAME

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on 2/5/03.


Marilyn E. Gordon

TECHNOLOGY CENTER 2800

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AMENDMENT

Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed November 8, 2002, please amend the subject application and consider Applicant's remarks as follows:

IN THE CLAIMS:

Please cancel claim 11 without prejudice or disclaimer to the subject matter disclosed therein.

Please amend claim 10 as follows:

10. (Amended) A semiconductor laser device comprising:
- an etching control layer, which is formed on a first region of a compound semiconductor substrate and has a composition different from a composition of the substrate;
 - a first semiconductor laser structure, which is defined over the etching control